

Form PTO-1449
(Rev. 8-83)

APR 15 2002

U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2101

Serial No. 09/502,675

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 11, 2000

Group Art Unit: 2812

OTHER DOCUMENT

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner
Initial

Inventors: Shunpei YAMAZAKI et al., "Semiconductor Device and Fabrication Method Thereof" Filing Date: July 5, 2000, Specifications and Drawings for Application Serial No. 09/610,217

Inventors: Shunpei YAMAZAKI et al., "Semiconductor Device and Manufacturing Method Thereof" Filing Date: July 6, 2000, Specifications and Drawings for Application Serial No. 09/610,753

Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Method of Fabricating the Same" Filing Date: December 23, 1999, Specifications and Drawings for Application Serial No. 09/471,359

Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Fabrication Method Thereof" Filing Date: February 22, 2000, Specifications and Drawings for Application Serial No. 09/510,734

Inventor: Shunpei YAMAZAKI, "Method for Manufacturing an Electrooptical Device" Filing Date: March 22, 2000, Specifications and Drawings for Application Serial No. 09/533,175

Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Method of Manufacturing the Same" Filing Date: February 7, 2000, Specifications and Drawings for Application Serial No. 09/498,646

RECEIVED
APR 17 2002
TC 2800 MAIL ROOM

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

04/04/2002